



RECEIVED

FEB 04 2004

TC 1700

PATENT

Customer No. 22,852

Attorney Docket No. 07553.0029

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Masaaki HAGIHARA et al.

Application No.: 10/030,656

Filed: January 11, 2002

For: ETCHING METHOD AND  
PLASMA PROCESSING METHOD

)  
)  
) Group Art Unit: 1763  
)  
) Examiner: A. Olsen  
)  
)  
)  
)  
)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a two-month extension of time to reply to the Office Action of August 26, 2003. A fee payment of \$420.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: January 26, 2004

By: David W. Hill  
David W. Hill  
Reg. No. 28,220

FINNEGAN  
HENDERSON  
FARABOW  
GARRETT &  
DUNNER LLP

1300 I Street, NW  
Washington, DC 20005  
202.408.4000  
Fax 202.408.4400  
www.finnegan.com

01/29/2004 WABDELRI 00000004 10030656

01 FC:1252

420.00 OP